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Advanced Laser Manufacturing Technology

Bingheng Lu
Huaming Wang
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## Contents

<table>
<thead>
<tr>
<th>Page</th>
<th>Title</th>
<th>Conference ID</th>
</tr>
</thead>
<tbody>
<tr>
<td>vii</td>
<td>Authors</td>
<td></td>
</tr>
<tr>
<td>ix</td>
<td>Conference Committees</td>
<td></td>
</tr>
<tr>
<td>xi</td>
<td>Introduction</td>
<td></td>
</tr>
<tr>
<td></td>
<td><strong>ADVANCED LASER MANUFACTURING TECHNOLOGY</strong></td>
<td></td>
</tr>
<tr>
<td>10153 01</td>
<td>Delay time dependence of thermal effect of combined pulse laser machining</td>
<td>[10153-8]</td>
</tr>
<tr>
<td>10153 02</td>
<td>Analysis of the spontaneous Rayleigh-Brillouin scattering spectra of N&lt;sub&gt;2&lt;/sub&gt;</td>
<td>[10153-9]</td>
</tr>
<tr>
<td>10153 03</td>
<td>Attenuation characteristic of UWB signals propagation in free space</td>
<td>[10153-10]</td>
</tr>
<tr>
<td>10153 04</td>
<td>Algorithm research on infrared imaging target extraction based on GAC model</td>
<td>[10153-11]</td>
</tr>
<tr>
<td>10153 05</td>
<td>Distance measurement to high remote targets based on the airborne chaotic laser</td>
<td>[10153-12]</td>
</tr>
<tr>
<td>10153 06</td>
<td>Laser pulse peak holding circuit for low cost laser tracking applications</td>
<td>[10153-13]</td>
</tr>
<tr>
<td>10153 07</td>
<td>The feature extraction of “cat-eye” targets based on bi-spectrum</td>
<td>[10153-15]</td>
</tr>
<tr>
<td>10153 08</td>
<td>Dual station visualization measuring method of LRCS</td>
<td>[10153-16]</td>
</tr>
<tr>
<td>10153 09</td>
<td>Fast computation of radiation pressure force exerted by multiple laser beams on red blood cell-like particles</td>
<td>[10153-17]</td>
</tr>
<tr>
<td>10153 0A</td>
<td>Photoacoustic signals denoising of the glucose aqueous solutions using an improved wavelet threshold method</td>
<td>[10153-18]</td>
</tr>
<tr>
<td>10153 0B</td>
<td>Simulation study on thermal effect of long pulse laser interaction with CFRP material</td>
<td>[10153-19]</td>
</tr>
<tr>
<td>10153 0C</td>
<td>Coherence length tunable solid-state lasers based on Fabry-Perot etalon</td>
<td>[10153-20]</td>
</tr>
<tr>
<td>10153 0D</td>
<td>Study of fuzzy adaptive PID controller on thermal frequency stabilizing laser with double longitudinal modes</td>
<td>[10153-21]</td>
</tr>
<tr>
<td>10153 0E</td>
<td>Application research of rail transit safety protection based on laser detection</td>
<td>[10153-22]</td>
</tr>
<tr>
<td>10153 0F</td>
<td>Two dimension interferometric Rayleigh scattering velocimetry</td>
<td>[10153-23]</td>
</tr>
<tr>
<td>10153 0G</td>
<td>Research on the method of precise alignment technology of atmospheric laser communication</td>
<td>[10153-24]</td>
</tr>
<tr>
<td>Paper Number</td>
<td>Title</td>
<td>Reference</td>
</tr>
<tr>
<td>--------------</td>
<td>----------------------------------------------------------------------</td>
<td>-----------</td>
</tr>
<tr>
<td>10153 OH</td>
<td>Observation of the Impact of angle of cylinder wedge on wedge waves by laser ultrasound technique</td>
<td>[10153-25]</td>
</tr>
<tr>
<td>10153 OI</td>
<td>Application of lap laser welding technology on stainless steel railway vehicles</td>
<td>[10153-26]</td>
</tr>
<tr>
<td>10153 OJ</td>
<td>Detection of cat-eye effect echo based on unit APD</td>
<td>[10153-27]</td>
</tr>
<tr>
<td>10153 OK</td>
<td>Optical property of few-mode fiber with non-uniform refractive index for cylindrical vector beam generation</td>
<td>[10153-29]</td>
</tr>
<tr>
<td>10153 OL</td>
<td>Optical system design of subminiature endoscope with imaging fiber bundle</td>
<td>[10153-30]</td>
</tr>
<tr>
<td>10153 OM</td>
<td>Study of laser location based on four-quadrant detector APD</td>
<td>[10153-31]</td>
</tr>
<tr>
<td>10153 ON</td>
<td>Application of drive circuit based on L298N in direct current motor speed control system</td>
<td>[10153-32]</td>
</tr>
<tr>
<td>10153 OO</td>
<td>Objective backscattering properties measurements at 2.52 terahertz</td>
<td>[10153-33]</td>
</tr>
<tr>
<td>10153 OP</td>
<td>Controlling software development of CW terahertz target scattering properties measurements based on LabVIEW</td>
<td>[10153-34]</td>
</tr>
<tr>
<td>10153 OQ</td>
<td>Simulation research on 2.52THz radar cross section of conductive column array</td>
<td>[10153-35]</td>
</tr>
<tr>
<td>10153 OR</td>
<td>The optimizations of CGH generation algorithms based on multiple GPUs for 3D dynamic holographic display</td>
<td>[10153-36]</td>
</tr>
<tr>
<td>10153 OS</td>
<td>Hybrid modulation driving power technology for pulsed laser fuze</td>
<td>[10153-37]</td>
</tr>
<tr>
<td>10153 OT</td>
<td>Design of high-precision ranging system for laser fuze</td>
<td>[10153-38]</td>
</tr>
<tr>
<td>10153 OU</td>
<td>Design of drive circuit of laser diode</td>
<td>[10153-40]</td>
</tr>
<tr>
<td>10153 OV</td>
<td>Comparative research on the methods for measuring the mode deflection angle of cylindrical resonator gyroscope</td>
<td>[10153-41]</td>
</tr>
<tr>
<td>10153 OW</td>
<td>Laser positioning of four-quadrant detector based on pseudo-random sequence</td>
<td>[10153-43]</td>
</tr>
<tr>
<td>10153 OX</td>
<td>Theoretical analysis of temperature response of the fiber Bragg grating embedded in composite insulator</td>
<td>[10153-42]</td>
</tr>
<tr>
<td>10153 OY</td>
<td>Effect on operating distance of laser rangefinders with deviation between axis of emitting and receiving in turbulent atmosphere</td>
<td>[10153-44]</td>
</tr>
<tr>
<td>10153 OZ</td>
<td>Experimental study of 248nm excimer laser etching of alumina</td>
<td>[10153-45]</td>
</tr>
<tr>
<td>10153 10</td>
<td>Transient elastic deformation detection on the metal surface induced by nanosecond laser pulse</td>
<td>[10153-46]</td>
</tr>
<tr>
<td>10153 11</td>
<td>An ultra-narrow-band optical filter based on whispering-gallery-mode hybrid-microsphere-cavity</td>
<td>[10153-47]</td>
</tr>
</tbody>
</table>
Research on the efficiency of coherent balanced detection [10153-49]

Dynamic calibration technique for inertial navigation system based on one-dimensional laser Doppler velocimeter [10153-50]

The design of Gaussian beam zoom system in intermediate and long distance measurement [10153-51]

Simulation and experiment of near-field nanostructuring on Ti-6Al-4V surface [10153-53]

Improved pulse laser ranging algorithm based on high speed sampling [10153-52]

Research on marking lines of silicone elastomer PDMS for super-hydrophobic surface fabrication based on picosecond laser [10153-54]

A colour image reproduction framework for 3D colour printing [10153-55]

Laser range profile of cones [10153-56]

High speed sampling circuit design for pulse laser ranging [10153-58]
Authors

Numbers in the index correspond to the last two digits of the six-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first four digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Ai, Yong, 12
Cao, Ercong, 0M, 0W
Cao, Guohuaa, 08
Chen, De-Ying, 0O, 0P, 0Q
Chen, Jian, 0G
Chen, Qian, 0M
Chen, Shanshan, 0T
Chen, Wen, 0X
Chen, Wen-jian, 0G
Chen, Yang, 12
Chen, Yong, 06
Chen, Yu-dan, 0Y
Dong, Shiyun, 17
Dong, Xiaopeng, 0X
Duan, Yuan-yuan, 0G
Fan, Chang-Kun, 0O, 0P
Fan, Guihua, 07
Fan, Youchen, 04
Fan, Yuanyuan, 0C
Fan, Zhenfang, 0V
Fang, Xiaodong, 0Z
Gang, Xiao, 17
Gao, Chunfeng, 13
Gao, Wei, 0G
Gao, Xuan-yi, 16, 1A
Gong, Lei, 19
Gong, Yanjun, 19
Gou, Ming-Jiang, 09
Gu, Guohua, 0M, 0W
Guo, Hai-chao, 16, 1A
Guo, Xiao-kang, 16, 1A
Guo, Xing, 0M
Han, Qingbang, 0H
Han, Sen, 0N
He, Guangzhong, 0I
He, Shi-jie, 16, 1A
He, Xingdao, 02
He, Ying-hong, 0L
Hu, Hongtao, 02
Hu, Wen-Gang, 0J
Hu, Xiaobo, 0M, 0W
Hu, Zhi-yun, 0F
Huang, Jianyu, 10, 15
Huang, Xuegong, 0U
Huang, Zhonghua, 03
Ji, Fengzhu, 12
Jia, Bing, 08
Jia, Jing, 0H
Jin, Guangyong, 01, 0B
Kou, Renke, 05
Li, Changjun, 1B
Li, Hongye, 0K
Li, Huan, 16, 1A
Li, Meng, 03
Li, Qi, 0O, 0P, 0Q
Li, Qian, 0Q, 0Q
Li, Ting, 0L
Li, Wei, 0l
Li, Xin, 0R
Li, Yingchun, 04
Li, Yuchen, 0N
Liu, Guodong, 0A
Liu, Hongyang, 12
Liu, Jie, 0J
Liu, Juan, 0R
Liu, Ligu, 0I
Liu, Linaian, 11
Long, Xingwu, 13
Lu, Qingjie, 0N
Lv, Juan, 0L
Lv, Qiongyinga, 0B
Ma, Jianhui, 0X
Ma, Shi-we, 0G
Ma, Xiangfang, 0X
Ma, Xiao-long, 0L
Ma, Yao, 01, 0B
Mo, Qiankai, 0D
Pan, Yao, 0V
Qian, Ru-hai, 16, 1A
Qian, Weixian, 0M, 0W
Qian, Xian-mei, 0Y
Qu, Tianliang, 0V
Ran, Yingying, 0U
Ren, Zhong, 0A
Shao, Jingzhen, 0Z
Shao, Jun, 0F
Shen, Zhonghua, 0H
Sheng, Xin-Qing, 09
Sha, Lin, 10, 15
Si, Jinhai, 0F
Sohib, Ali, 18
Song, Chaoqun, 17
Song, Xingliang, 0C
Sun, Bing, 0K
Sun, Hao, 0N
Sun, Huayan, 07
Sun, Pei-ll, 18
Tang, Yanqin, 0W
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Introduction

We had the great honor of organizing the International Symposium on Advanced Laser Manufacturing Technology 2016. It was truly a great pleasure for us to greet the more than 1000 participants from many different countries who attended the symposium. We firmly believe the symposium will become an important international event in the field of optical technology.

The International Symposium on Advanced Laser Manufacturing Technology is sponsored by Chinese Society for Optical Engineering and China High-tech Industrialization Association (CHIA), organized by Chinese Society for Optical Engineering (CSOE), Photoelectronic Technology Committee, Chinese Society of Astronautics, Photo-electronic Industrialization Committee, CHIA, Department of Cooperation and Coordination for Industry, Academe and Research, CHIA.

The purpose of the symposium is to provide a forum for the participants to report and review innovative ideas and up-to-date progress and developments, and discuss novel approaches to application in the optical field. It is sincerely hoped that the research and development in optical field will be promoted, and the international cooperation sharing the common interest be enhanced.

On behalf of the other co-chairmen, and the Organization Committee of the conference, we would like to heartily thank our sponsors and cooperating organizers for all they have done for the symposium. Thanks also to all the authors for their contributions to the proceedings, to all of the participants and friends for their interest and efforts in helping us to make the symposium possible, to the Program Committee for their effective work and valuable advice, especially the Secretariat, and to the SPIE staff for their tireless efforts and outstanding service in preparing the symposiums and publishing the proceedings.

Bingheng Lu
Huaming Wang